



ECLIPSE LV100N POL LED Ci-POL

Polarizing Microscopes



The highest level of optical quality, operability and stability for polarizing microscopy



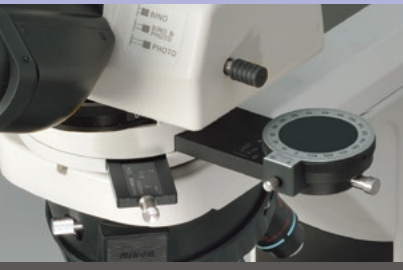
Reversed centering quintuple nosepiece

Up to five objectives can be mounted and all objective positions are centerable. The DIN-compliant compensator slot accepts various compensators for qualitative or quantitative measurements.



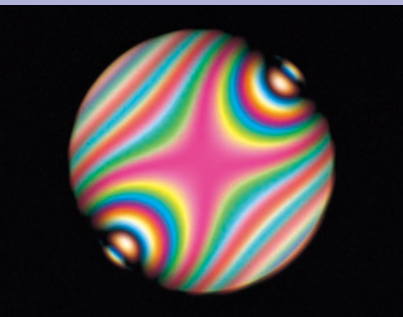
High-precision rotating stage

The LV100N POL LED stage is large, pre-adjusted, and click-stops in 45° increments. The smooth stage movement allows stable and easy rotation, providing high operability and high-quality polarized images. The underneath support for the stage table is close to the optical axis. Together with the steel cross roller guides, this provides outstanding stability and durability during regular use.



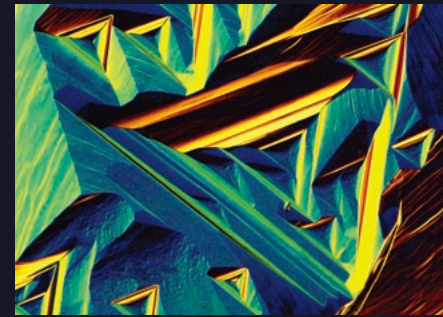
Intermediate tube

The intermediate tube incorporates a Bertrand lens as standard, enabling both the observation and capture of conoscopic and orthoscopic images. The Bertrand lens is focusable and centerable. The high precision slider-type analyzer can be rotated a full 360° with a precision vernier scale. A P-CL tint plate slider with full and quarter wave plates and an empty space is available.

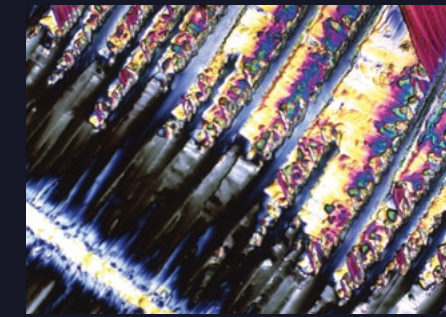


Conoscopic image of mica / CFI Achromat P 40X

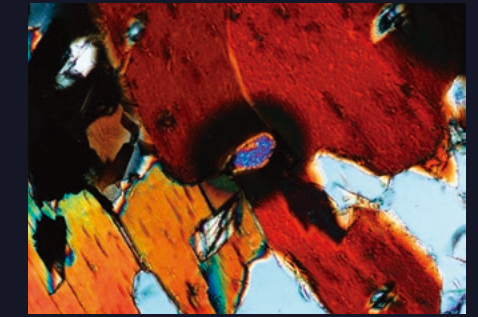
- LV100N POL LED is equipped with a bright and long-life LED light source with reduced heat-induced focus drift.
- Centerable nosepiece with high precision.
- The LV100N POL LED's stage provides smooth, accurate movement.
- 30mm long focus stroke accepts tall samples.



1



2



3



ECLIPSE Ci-POL
(Diascopic illumination)

ECLIPSE Ci-POL
(Diascopic/Episcopic illumination)

ECLIPSE LV100N POL LED
(Diascopic illumination)

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Objectives for polarizing observation

CFI Achromat P objective series (for diascopic illumination)

The unique Nikon CFI60 objectives successfully deliver longer standard working distances and high numerical apertures, offering superb image flatness, contrast and cost performance.



CFI TU Plan Fluor EPI P objective series (for diascopic/episcopic illumination)

The CFI TU Plan Fluor EPI P series of CFI60-2 objectives produce pin-sharp aberration-free images regardless of magnification.



Nikon CFI optics employ an eco-glass that is manufactured with no harmful substances such as lead and arsenic.

ECLIPSE LV100N POL LED Diascopic illumination type

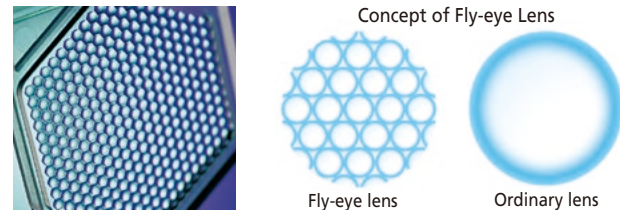
Outstanding optical performance, perfect for a wide variety of imaging applications and polarizing techniques

LV100N POL LED is equipped with a bright and long-life LED light source. LEDs generate very little heat, greatly reducing focus drift resulting from light source heat.

- Microscope body is designed to realize high robustness.
- Unique stage mount design ensures exceptional stability.
- Nosepiece comes with a DIN standard compensator slot.
- All five objective positions on the nosepiece are centerable.
- Uses CFI60 optics, realizing both high NA and longer standard working distances.
- A clamp-type upper limit focusing mechanism makes for easy, safe sample exchange, protecting both sample and optics from collision damage.

Uniform brightness with diascopic illumination

Nikon's unique fly-eye lens has been employed in diascopic illumination optics. This enables high quality imaging with no variations in luminescence throughout the view field.



ECLIPSE LV100N POL LED Diascopic/Episcopic illumination type ECLIPSE Ci-POL Diascopic/Episcopic illumination type

Accomplishes advanced polarizing microscopy under both diascopic and episcopic illumination

Both diascopic and episcopic polarizing observations are possible by mounting the LV-UEPI-N Universal Epi-illuminator. It is possible to switch between the illumination techniques of the LV100N POL LED with a simple operation. The epi-illuminator uses a bright, long-life LED light source. The noise-terminator mechanism provides sharp images with high S/N ratios by eliminating stray light. With the optional universal-type nosepiece and DIC accessories including objectives, episcopic differential interference contrast (DIC) microscopy is also possible.



ECLIPSE Ci-POL

(Diascopic/Episcopic illumination type)

* When used with the Ci-POL, LV-UEPI-N requires an external power supply.

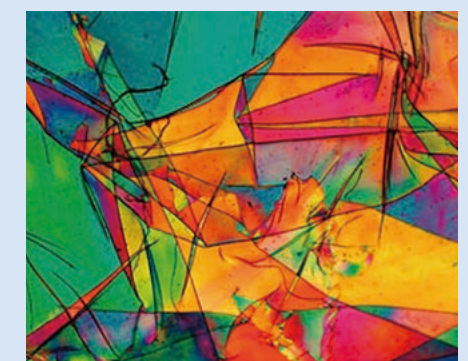
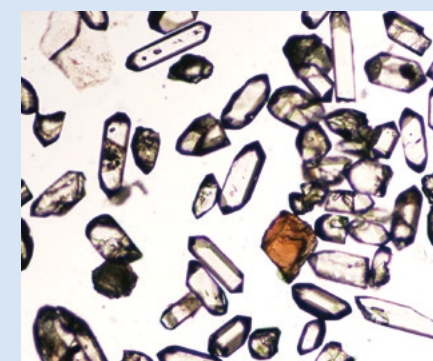
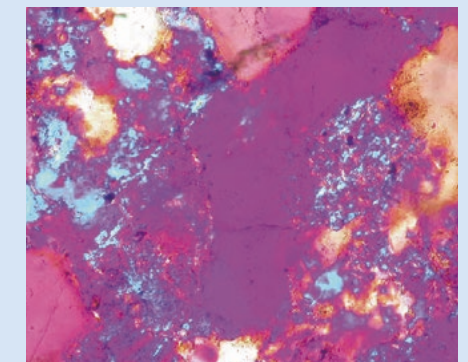
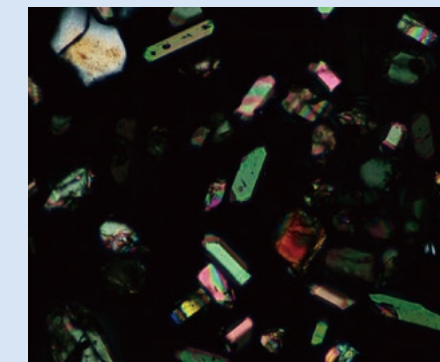
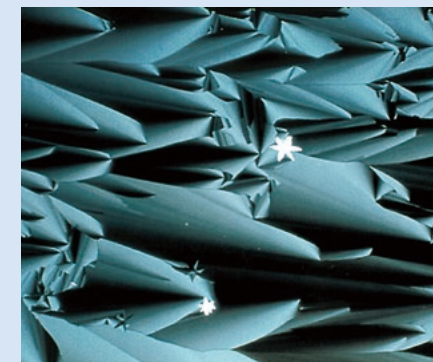


ECLIPSE LV100N POL LED
(Diascopic/Episcopic illumination type)

ECLIPSE Ci-POL Diascopic illumination type

A compact polarizing microscope that balances basic performance and ease of use

- Slim and compact, an excessively large working area is not necessary.
- Nosepiece uses the same DIN standard compensator slot design as LV100N POL LED.
- All five objective positions on the nosepiece are centerable.
- Uses CFI60 optics, realizing both high NA and long standard working distances.
- A clamp-type upper limit focusing mechanism makes for easy, safe sample exchange, protecting both sample and optics from collision damage.
- Excellent cost effective and precision manufacturing is balanced with superb basic performance for a polarizing microscope.
- Built-in capture button allows easy imaging with the Digital Sight series cameras (Please see page 6).
- Built-in 6V 30W halogen light source.

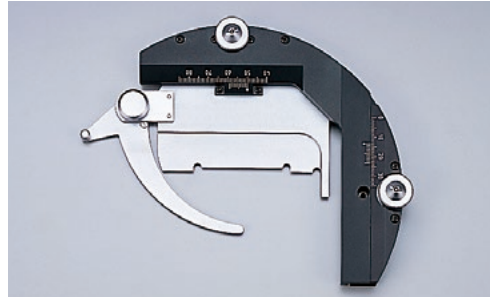


Optional Accessories for Polarizing Observations

Attachable mechanical stage

To improve microscopy efficiency, an attachable mechanical stage can be mounted on the rotating stage to rigidly hold and move the sample.

Cross travel: 35 x 25 mm
Minimum increment: 0.1mm on the vernier



Senarmont compensator

Inserted into the intermediate tube. In addition to the standard use 1/4 λ plate and a 546 nm (1 λ) tint plate (1st order red plate), a Senarmont compensator is also available as an option, for retardation measurements from 0 to 1 λ .



Quartz wedge compensator

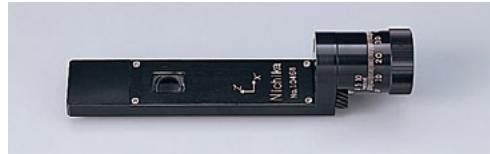
Inserted into the intermediate tube, this compensator permits retardation measurements from 1 to 6 λ orders.



Berek compensator

Inserted into the nosepiece slot, this compensator permits retardation measurements from 0 to 1800 nm.

Manufactured by Nichika Corporation.



IF 546/12 retardation filter

High-precision interference filter with a 546 nm central wavelength and 12 nm FWHM (full-width at half maximum). Used to increase the precision of retardation measurements.

Digital Camera for Microscopes

When the Digital Sight 100 and Digital Sight 10 cameras are connected directly to a PC, the NIS-Elements software allows the acquisition, processing, measurement and analysis of images, as well as data management and report creation.

C-mount camera

Digital Sight 100 Microscope Camera

This C-mount color camera, equipped with a 1-inch color CMOS image sensor, has a high pixel count of 17.7-megapixels, enabling it to capture clear images with a wide field of view. Its excellent color reproducibility and high-speed live image display enable smooth image acquisition. It also enables the microscope image being observed to be output to a monitor via HDMI connection.



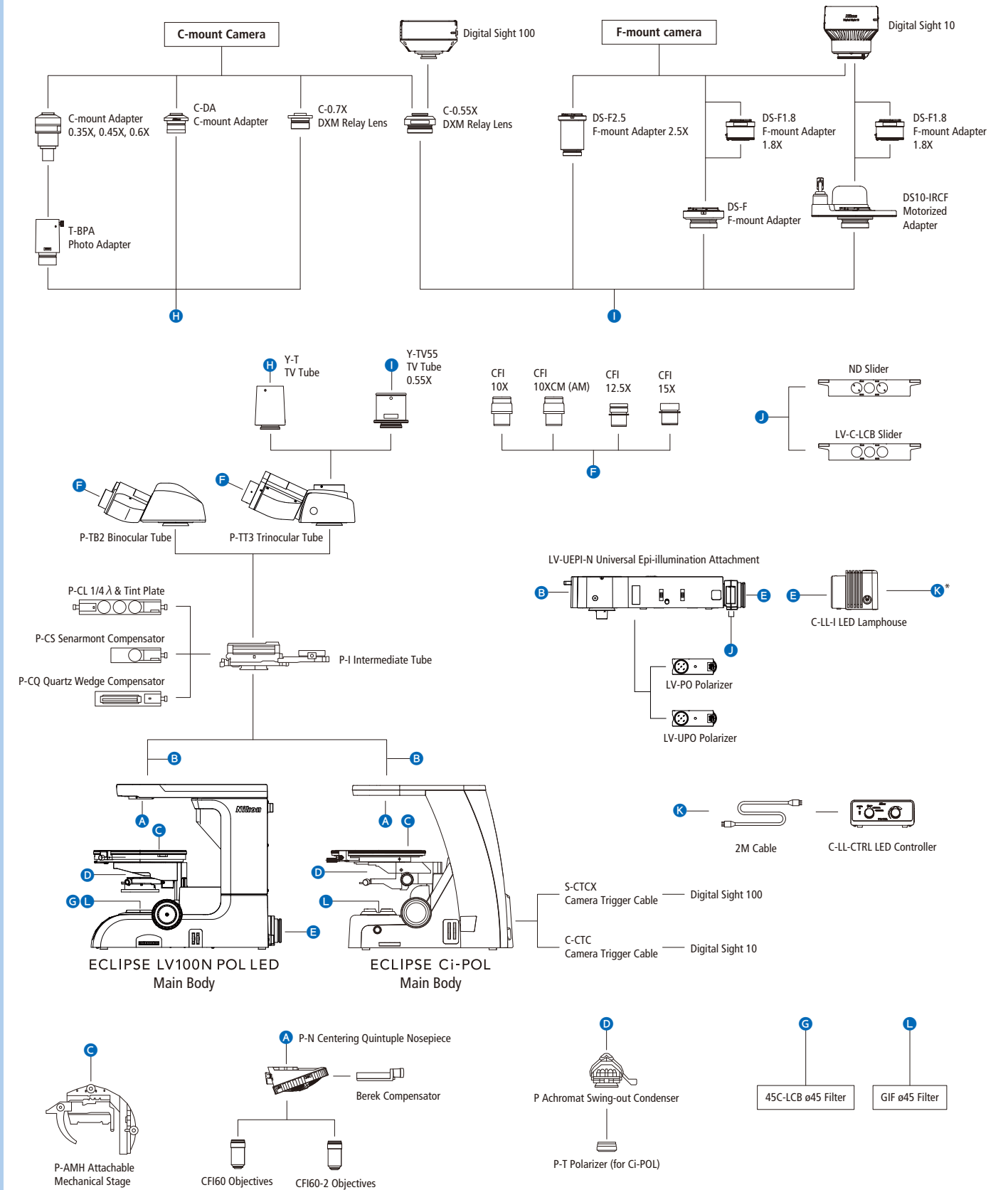
F-mount camera

Digital Sight 10 Microscope Camera

This high-resolution camera captures both color and monochromatic images at up to 6,000 x 3,984 pixels. This enables the wide range of images to be captured and then many of them to be stitched together making a single and large combined image.



System Diagram

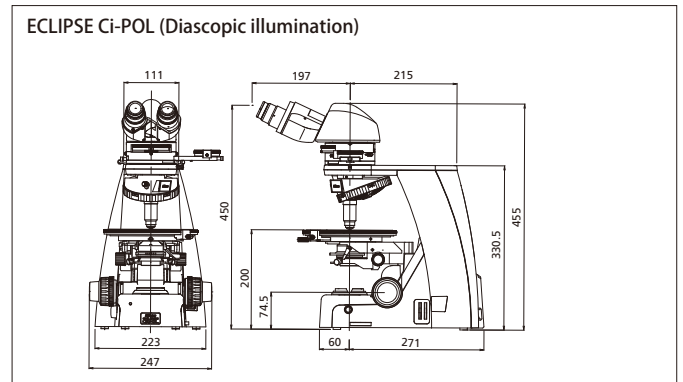
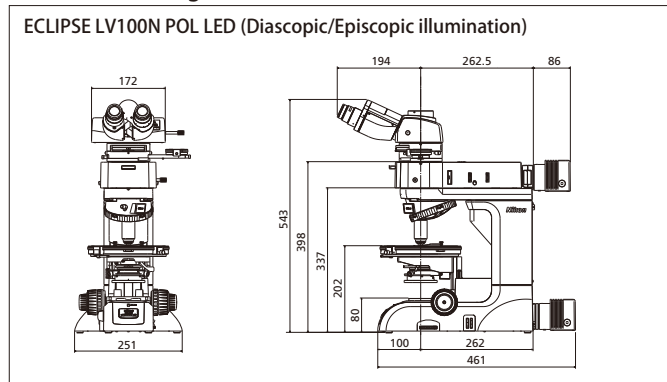


* Ci-POL requires the C-LL-CTRL. LV100N POL LED requires the C-LL-CTRL only when simultaneously using episcopic and diascopic illumination.

Specifications

		ECLIPSE LV100N POL LED	ECLIPSE Ci-POL
Main body	Optical system	CFI60 infinity	
	Illumination	High color rendering LED; 12V-24W power supply built-in; Diascopic/episcopic illumination changeover switch; Fly-eye lens; NCB11, ND8 filters built-in	6V-30W halogen lamp; 6V-30W power supply built-in; ND8, ND4 filters built-in
	Focusing	Coaxial coarse/fine focus knob; Focus stroke: 30mm; Coarse: 14mm per rotation; Fine: 0.1mm; Minimum reading: in 1µm increments	Coaxial coarse/fine focus knob; Focus stroke: 30mm; Coarse: 9.33mm per rotation; Fine: 0.1mm; Minimum reading: in 1µm increments
Eyepieces (FN)		CFI 10X (22), CFI 10X CM (22), CFI 12.5X (16), CFI 15X (14.5)	
Tubes		P-TT3 Trinocular Tube for polarizing microscopy; P-TB2 Binocular Tube for polarizing microscopy	
Intermediate tube		Built-in focusable Bertrand lens removable from optical path; Conoscopic/Orthoscopic observations switchable; Analyzer built-in; Accessory plate/compensator slot	
Analyzer		360° rotary dial; Minimum reading angle 0.1°	
Nosepiece		Centering quintuple nosepiece (detachable); DIN slot	
Stages		Top-grade dedicated circular graduated stage Rotatable 360° horizontally; can be fixed at a specific position; Graduated 360° (in 1° increments); Click stops each 45°; Attachable mechanical stage: 35 x 25 mm travel; vernier 0.1mm	Ball bearing rotary stage; Rotatable 360° horizontally; can be fixed at a specific position; Graduated 360° (in 1° increments); Rotation clamp equipped; Attachable mechanical stage: 35 x 25 mm travel; vernier 0.1mm
Condenser		Dedicated strain-free swing-out type; P Achromat NA 0.9	
Polarizers		Fixed to the bottom of the condenser holder; with scale markings	No scale markings
Objectives (Polarizing sets)		CFI Achromat P 4X, P 10X, LWD P 20X, P 40X, P 100X Oil CFI TU Plan Fluor EPI P 5X, P 10X, P 20X, P 50X, P 100X	
Episcopic illuminator		LV-UEPI-N Universal Epi-illuminator (The LV100N POL LED has a built-in 12V-24W power supply)	LV-UEPI-N Universal Epi-illuminator (The Ci-POL requires an external power supply C-LL-CTRL)
Compensators		P-CL Standard 1/4 λ & tint plate, quartz wedge or Senarmont compensator can be inserted into intermediate tube slot	
Power consumption		0.7A/58W	0.8A/38W
Weight		Approx. 17kg (standard trinocular set)	Approx. 14kg (standard binocular set)

Dimensional Diagram



Unit: mm

Images courtesy of:
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